

<b>Notice of References Cited</b>	Application/Control No. 10/527,683	Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
	Examiner Michelle Estrada	Art Unit 2823	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0051134 A1	03-2004	Jang et al.	257/316
*	B	US-6,475,854 B2	11-2002	Narwankar et al.	438/238
*	C	US-6,664,116 B2	12-2003	Li et al.	438/3
*	D	US-6,709,989 B2	03-2004	Ramdani et al.	438/763
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.